

Search Notes 	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10645892	BEDNAREK, MICHAEL C.
Examiner	Art Unit	
Michael Peffley	3739	

SEARCHED

Class	Subclass	Date	Examiner
606	41,48-50	1/21/09	/mp/
607	101-105	1/21/09	/mp/
update	above	9/16/09	/mp/
update	above	1/6/10	/mp/

SEARCH NOTES

Search Notes	Date	Examiner

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

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